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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re: the Application of: **YAMADA, Toshiro, et al.**

Group Art Unit: **1765**

Serial No.: **10/520,272**

Examiner: **Shamim Ahmed**

Filed: **January 14, 2005**

P.T.O. Confirmation No.: **4526**

FOR: **METHOD OF DRY ETCHING, DRY ETCHING GAS AND PROCESS FOR
PRODUCING PERFLUORO-2-PENTYNE**

REQUEST FOR STATUS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22131-1450

Date: July 13, 2006

Sir:

The undersigned attorney requests the status of the above-identified application.

The application was filed on **January 14, 2005** in the U.S. Patent and Trademark Office
and to date no Office Action has been received.

In the event any fees are required in connection with this paper, please charge Deposit
Account No. 01-2340.

Respectfully submitted,

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